

IFW

Docket No.: 1572.1251

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Sang-in LEE

Group Art Unit: 2857

Serial No. 10/791,808

Examiner: Patrick J. Assouad

Filed: March 4, 2004

For:

PERFORMANCE MEASUREMENT SYSTEM

COMMUNICATION TO EXAMINER

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

A Notice of Allowance was mailed on October 17, 2005 for the subject application. An Information Disclosure Statement was filed on November 30, 2005. A copy of the USPTO-stamped filing receipt along with the PTO-1449 Form is attached hereto. The Applicant respectfully requests that the Examiner acknowledge the references cited on the PTO-1449 Form.

Respectfully submitted

STAAS & HALSEY LI

1201 New York Ave, N.W., Suite 700

Washington, D.C. 20005 Telephone: (202) 434-1500 Deidre M. Davis
Registration No. 52,797



Please Date Stamp and return

INFORMATION DISCLOSURE STATEMENT ALONG WITH PTO-1449 (3 REFERENCES) AND CHECK FOR \$180.00

APPLICANT(S):

Sang-In LEE

SERIAL NO:

10/791,808

CONFIRMATION NO. 5234

TITLE:

PERFORMANCE MEASUREMENT SYSTEM

FILING DATE:

March 4, 2004

DOCKET NO:

1572.1251/GMG/DMD:jla

DUE DATE:

December 27, 2005





JAN 1 7 2006 W JAN 1 7 2006 W FORM PTO-1449 U.S. E PATEI

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Sang-In LEE
FILING DATE GROUP ART UNIT
March 4, 2004 2857

U.S. PATENT DOCUMENTS

*EXAMINER		DOCUMENT				SUB-	FILING
INITIAL		NO.	DATE	NAME	CLASS	CLASS	DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
		I	! i		1		ł

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO	ABSTRACT
A	.G	2002-208956	07/26/2002	Japan		Х
Al	Н	2002-008179	01/11/2002	Japan		X
Al	J					
A	'n					
Al	ĸ					
Al	L					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)				TRANSLATION YES NO	
	АМ	Korean Intellectual Property Office Notice of Official Action for corresponding Korean Patent Application No. 10-2003-0049307	х		

EXAMINER	DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant				